

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN THE MATTER OF: Jaehwan EUN, et al  
SERIAL NO: 10/539,886  
FILED: June 17, 2005 CONFIRMATION NO: 1951  
TITLE: METHOD FOR PREPARING FILM STRUCTURE  
COMPRISING FERROELECTRIC SINGLE  
CRYSTAL LAYER  
GROUP: 1791 EXAMINER: Sonya MAZUMDAR

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

SIR:

This Amendment is being filed concurrently with the filing of an RCE for the above-identified application. The Commissioner is hereby authorized to deduct any required fees in the prosecution of this application to Applicant's Deposit Account No. 504581.

Please amend the present application as follows: